

<b>Search Notes</b> 	<b>Application/Control No.</b>  10/609,018	<b>Applicant(s)/Patent under Reexamination</b>  BLAUVELT ET AL.
<b>Examiner</b>  Ellen Kim	<b>Art Unit</b>  2874	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
385/39,50,129,130		9/14/2005	EK